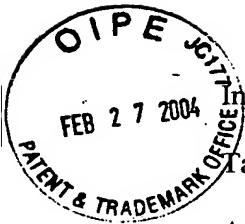


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re the Application of

Takao SAITO et al.

Application No.: 10/766,806

Filed: January 30, 2004

Docket No.: 115556

For: A METHOD AND SYSTEM FOR FORMING THIN FILMS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference 1 and 2 is discussed in the present specification.
- ☒ 3. An English-language Abstract of the non-English language reference 2 is attached hereto.
- ☒ 4. A computer-generated English translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See Reference 2.

Respectfully submitted,

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JAO:TJP/mlo  
Date: February 27, 2004

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Sheet 1 of 1Form PTO-1449  
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PATENT & TRADEMARK OFFICEATTY DOCKET NO.  
115556APPLICATION NO.  
10/766,806

## INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)  
Takao SAITO et al.FILING DATE  
January 30, 2004

GROUP

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	1.	JP A 62-136569	6/19/1987	JAPAN		
	2.	JP A 2002-339072 w/abstract & transl.	11/27/2002	JAPAN		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: February 27, 2004